

JUN 2 3 2004



Intellectual Property Law

Date:

June 23, 2004

TO:

Examiner

Anita Karen Alanko

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Art Unit: 1765

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Subject Matter:

10/077,720

Attorney Doc: 67,200-478

Message:

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 1765

Applicants: Yi-Nien Su

Group Arc Oute: Tie

Serial No.: 10/077,720

Examiner: Anita Karon Alanko

Filed: 02/15/2002

In Response to Office Action

Dated: March 23, 2004

For:

A METHOD FOR IMPROVED PLASMA ETCHING CONTROL

Attorney Docket No.: 67,200-478

Certificate of Facsimile Transmission

Thereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Patent Office on the date Flown below Via facsimile no. (703) 872-

Date: June 23, 2004

REQUEST FOR RECONSIDERATION

Commissioner for Patents P.O. Box 1450 Alexandria, Va 22313-1450

Dear Sir:

In response to a final Office Action mailed March 23, 2004, please enter the following amendments and consider the following remarks.